



PATENT APPLICATION
Do. No. 5204-22

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Young Suk LEE; Young Mook KANG; Sang Do LEE

Serial No. 09/914,306

Examiner: Crowell, Anna M

Confirmation No. 2394

Filed: July 16, 2002

Group Art Unit: 1763

For: PLASMA PROCESSING APPARATUS AND METHOD FOR
FORMING THIN FILMS USING THE SAME

8A
4/29/03
mw

BOX FEE AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Responsive to the Office Action, dated December 18, 2002, please amend the
application as follows.

04/24/2003 HGU/TEMA1 00000027 09914306

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